

ASMNUT.020A



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

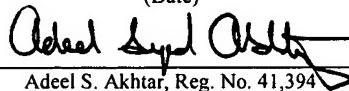
Applicant : Uzoh et al.
Appl. No. : 10/698,878
Filed : October 31, 2003
For : METHODS AND DEPOSITING
HIGH YIELD AND LOW
DEFECT DENSITY
CONDUCTIVE FILMS IN
DAMASCENE STRUCTURES
Examiner : Van, Luan V.
Group Art Unit : 1753

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 5, 2006

(Date)



Adeel S. Akhtar

Adeel S. Akhtar, Reg. No. 41,394

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action mailed on April 5, 2006. Please amend the above-identified application as set forth herein and consider the remarks that follow.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.